



ITW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Masaharu KAWAKUBO et al.

Group Art Unit: 2882

Application No.: 10/581,060

Examiner: C. RIDDLE

Filed: May 30, 2006

Docket No.: 127873

For: EXPOSURE METHOD AND DEVICE MANUFACTURING METHOD, EXPOSURE
APPARATUS, AND PROGRAM

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the October 27, 2009 Office Action, and in consideration of the January 21,
2010 personal interview with the Examiner, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.